EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	367	(wafer or substrate) with nozzle with etch $3 with (edge or peripheral)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/02/22 13:43
L2	34	(spin adj etching) same nozzle	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/02/22 13:43
L3	398	(wafer or substrate) with (nozzle or inlet) with etch$3 with (edge or peripheral)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/02/22 13:44
L4	9026	(wafer or substrate) same nozzle same (edge or peripheral)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/02/22 13:45
L5	906	((156/345.1) or (156/345.11) or (156/345.17) or (156/345.21)).CCLS.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/02/22 13:48
L6	91	4 and 5	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/02/22 13:48
L7	1	bogart-jeffery.in.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/02/22 13:48

L8	14	volodarsky-rimma.in.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/02/22 13:49

2/22/08 1:52:22 PM
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